



IPW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2824  
Examiner: To be assigned

In Re PATENT APPLICATION of:

Applicant(s): Kun-Hong CHEN

Serial No.: 10/781,778

Filed: February 20, 2004

For: METHOD FOR FABRICATING A LOW  
TEMPERATURE POLYSILICON THIN  
FILM TRANSISTOR

Atty Ref.: SUND 502

**STATUS REQUEST**

August 31, 2005

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir or Madam:

Please let us know the status of the above-identified application and when an action may be expected. Please respond via facsimile or e-mail to Tonya Harris (Docketing Manager) at [tharris@rabinberdo.com](mailto:tharris@rabinberdo.com). If the response to this status request is made by telephone, please ask for Tonya Harris (Docket Clerk) at extension 518.

Respectfully submitted,

August 31, 2005  
Date

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RHB/vm